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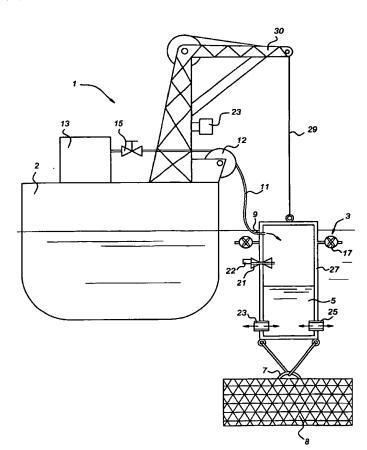
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(54) Title: FLOATING LOWERING AND LIFTING DEVICE



(57) Abstract: The invention relates to a floating lowering and lifting device (1) comprising a floating structure (2) and a lifting unit (3) lowerable from the floating structure (2) towards the sea bed, the lifting unit (3) having a chamber (5) with at least one gas-inlet opening (9) in its wall (27) and an equalisation opening (23, 25) in its wall (27), a gas supply means (13) being connected to the gas inlet opening (9), the device comprising a control means (15) connected to the gas supply means (13) for controlling a gas supply rate to the chamber (5), wherein the chamber (5) comprises a releasable coupling member (7) for releasably attaching to a load (8).